IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

attorney Docket No.: 1003-0610

Group Art Unit: 2812

Application of: Chiesl

Examiner: Viktor Simkovic

Serial No.: 09/960,441

Filed: September 21, 2001

ARRANGEMENT FOR MEASURING PRESSURE ON A For:

SEMICONDUCTOR WAFER AND AN ASSOCIATED METHOD FOR

FABRICATING A SEMICONDUCTOR WAFER

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to: Mail Stop AF, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on October 8, 2003 (Date of Deposit)

Harold C. Moore

Name of person-mailing Document or Fee

Signature

October 8, 2003

Date of Signature

PETITION FOR EXTENSION OF TIME

PURSUANT TO 37 C.F.R. § 1.136(a)

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Sir:

In connection with the Final Office Action mailed June 25, 2003 in the aboveentitled patent application, Applicant respectfully requests a one (1) month extension in which to file a response, from September 25, 2003 to October 25, 2003.

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110.00 OP

TECHNOLOGY CENTER 2800

The \$110.00 fee required by 37 C.F.R. § 1.136(a) is submitted herewith.

Respectfully Submitted,

Harold C. Moore

Attorney for Applicant Registration No. 37,892

October 8, 2003 Maginot, Moore & Bowman Bank One Center/Tower 111 Monument Circle, Suite 3000 Indianapolis, IN 46204-5130 (317) 638-2922